

Substitute for form 1449A/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				<b>Complete if Known</b>	
				Application No.	10/039,111
				Filing Date	January 4, 2002
				First Named Inventor	Venkatesh R. Iyer
				Art Unit	2145
				Examiner Name	Jeffrey R. Swearingen
Sheet	1	of	1	Attorney Docket Number	24523-09627

U.S. PATENT DOCUMENTS					
		Document No.			
Examiner Initials*	Cite No. <sup>1</sup>	Number – Kind Code <sup>2</sup> (if known)	Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
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FOREIGN PATENT DOCUMENTS					
		Foreign Patent Document			
Examiner Initials*	Cite No. <sup>1</sup>	Country Code <sup>3</sup> – Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T <sup>6</sup>

OTHER REFERENCES – NON-PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published			T <sup>6</sup>
	C1	BIERMAN, A. et al., Internet Draft: "Remote Monitoring MIB Extensions for Identifying Application Protocol Verbs," November 25, 2000, 22 pages, [online] Retrieved from the Internet<URL:http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-01>			
	C2	BIERMAN, A. et al., Internet Draft: "Remote Monitoring MIB Extensions for Identifying Application Protocol Verbs," July 17, 2001, 23 pages [online] Retrieved from the Internet<URL: http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-02>			
	C3	BIERMAN, A. et al, Internet Draft: "Remote Monitoring MIB Extensions for Identifying Application Protocol Verbs," July 14, 2000, 21 pages, [online] Retrieved from the Internet<URL: http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-00>			

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609.  
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